
“The instrument”

Lecture 4

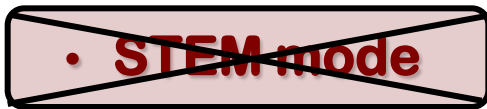
Review of imaging modes

System overview

Review of imaging modes

- Condenser system
- Objective lens & sample stage
- Forming images and diffraction patterns

- TEM mode



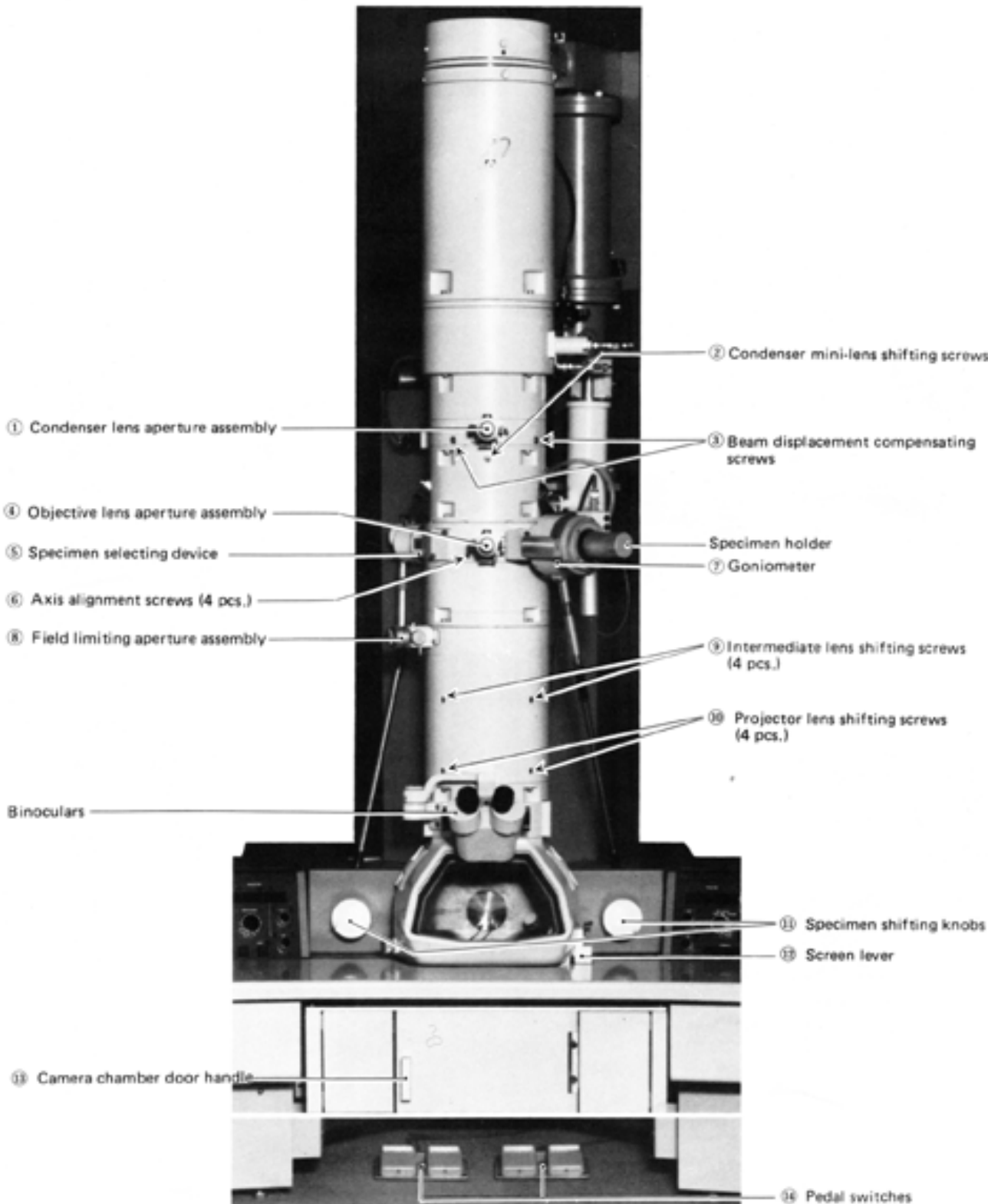
Microscope alignment

- Philosophy
- Step-by-step

Calibrations

- Magnification, camera length, rotation (if needed), convergence angle

TEM overview



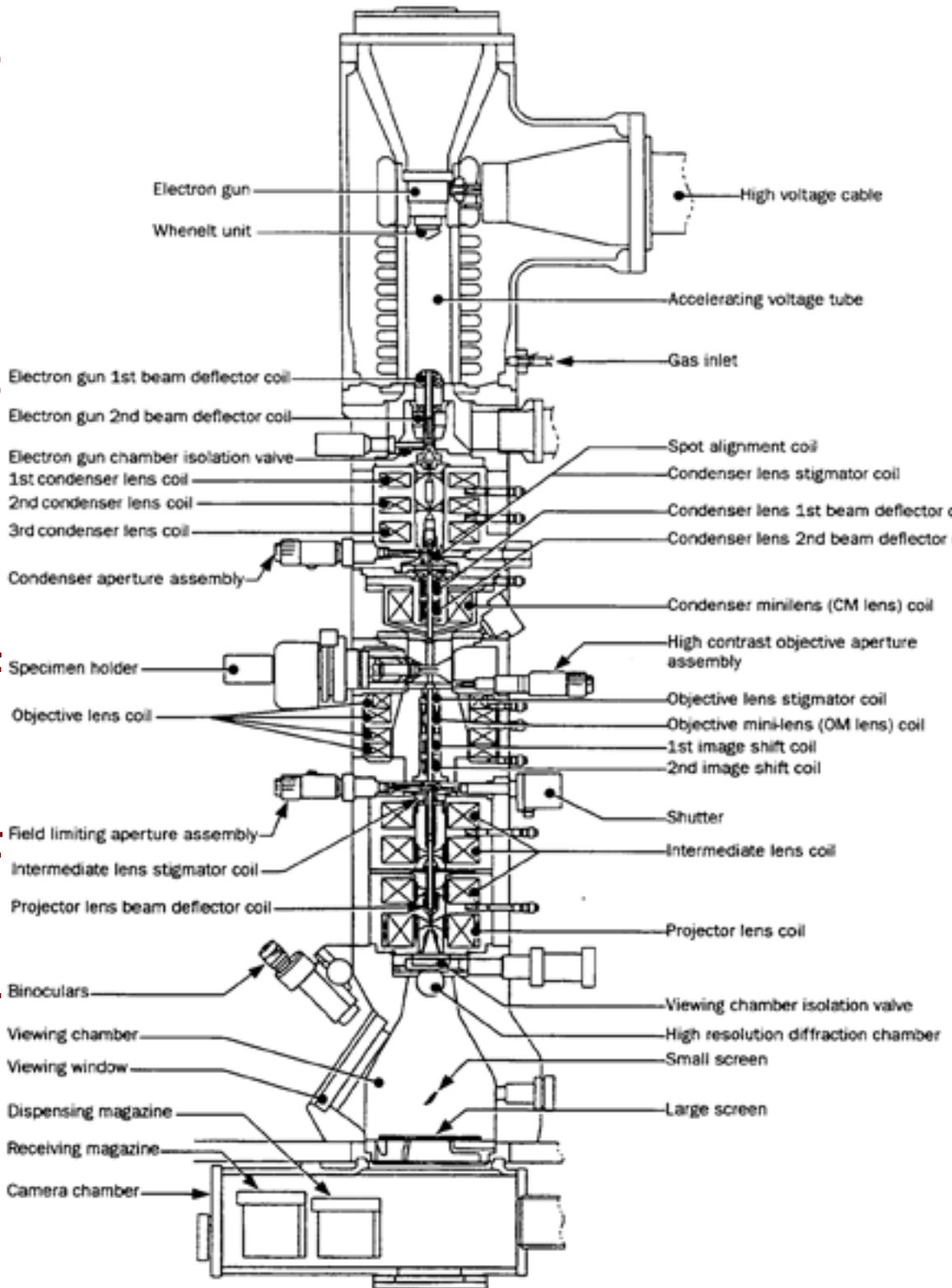
TEM cross section

Electron Gun

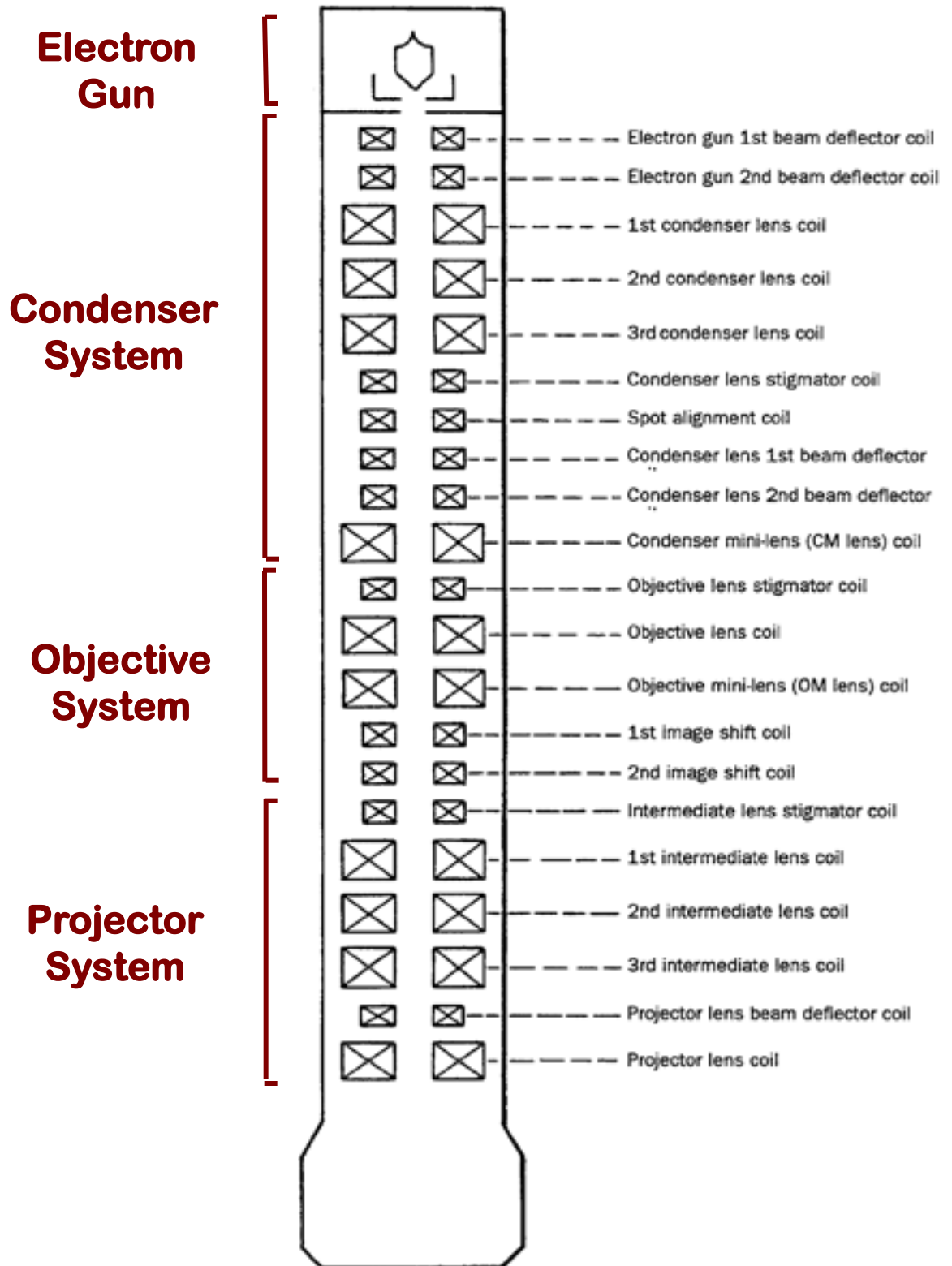
Condenser System

Objective System

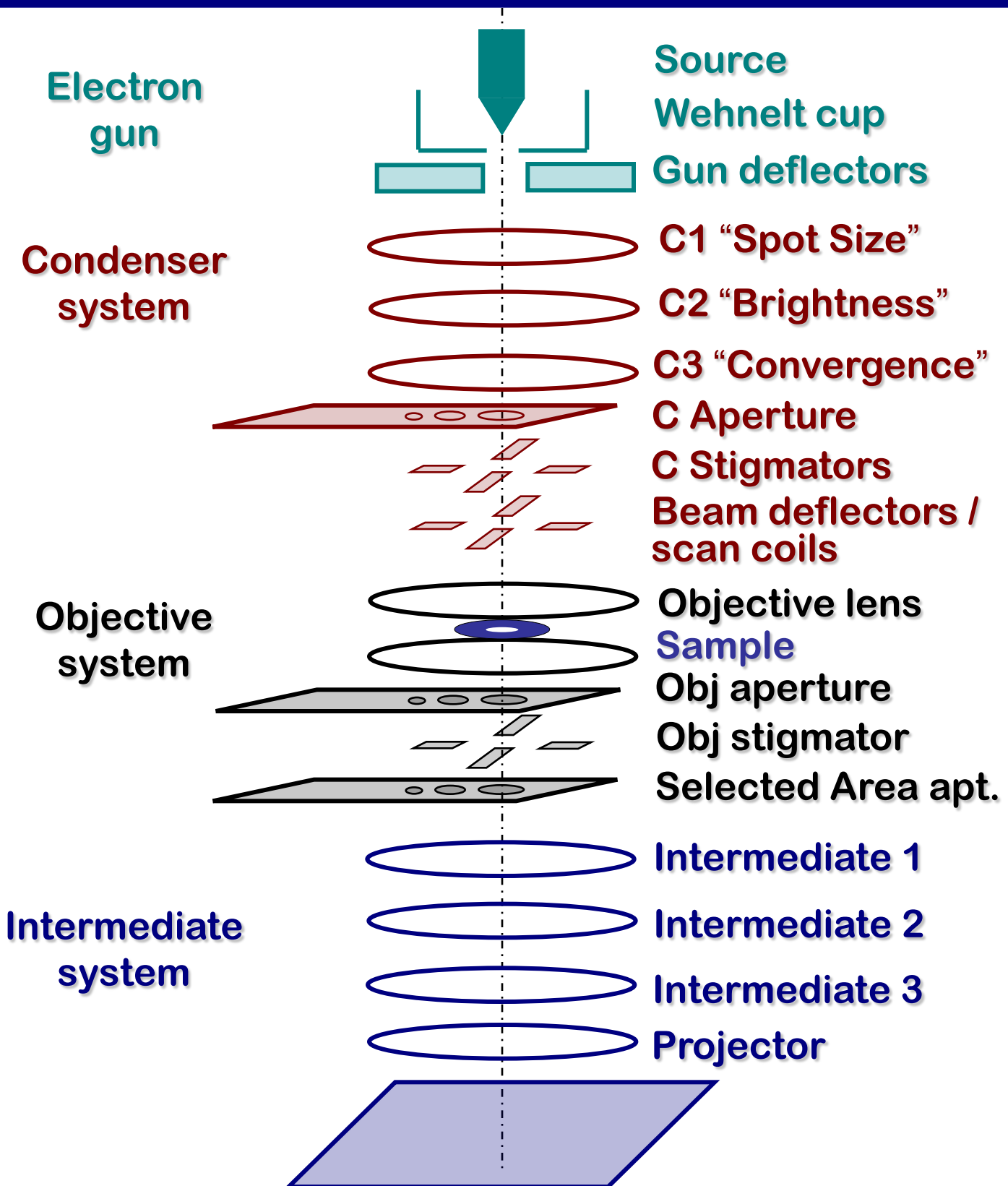
Projector System



TEM cross section (simplified - somewhat)



TEM cross section



Condenser system

Goal: place the beam on the sample

Variables:

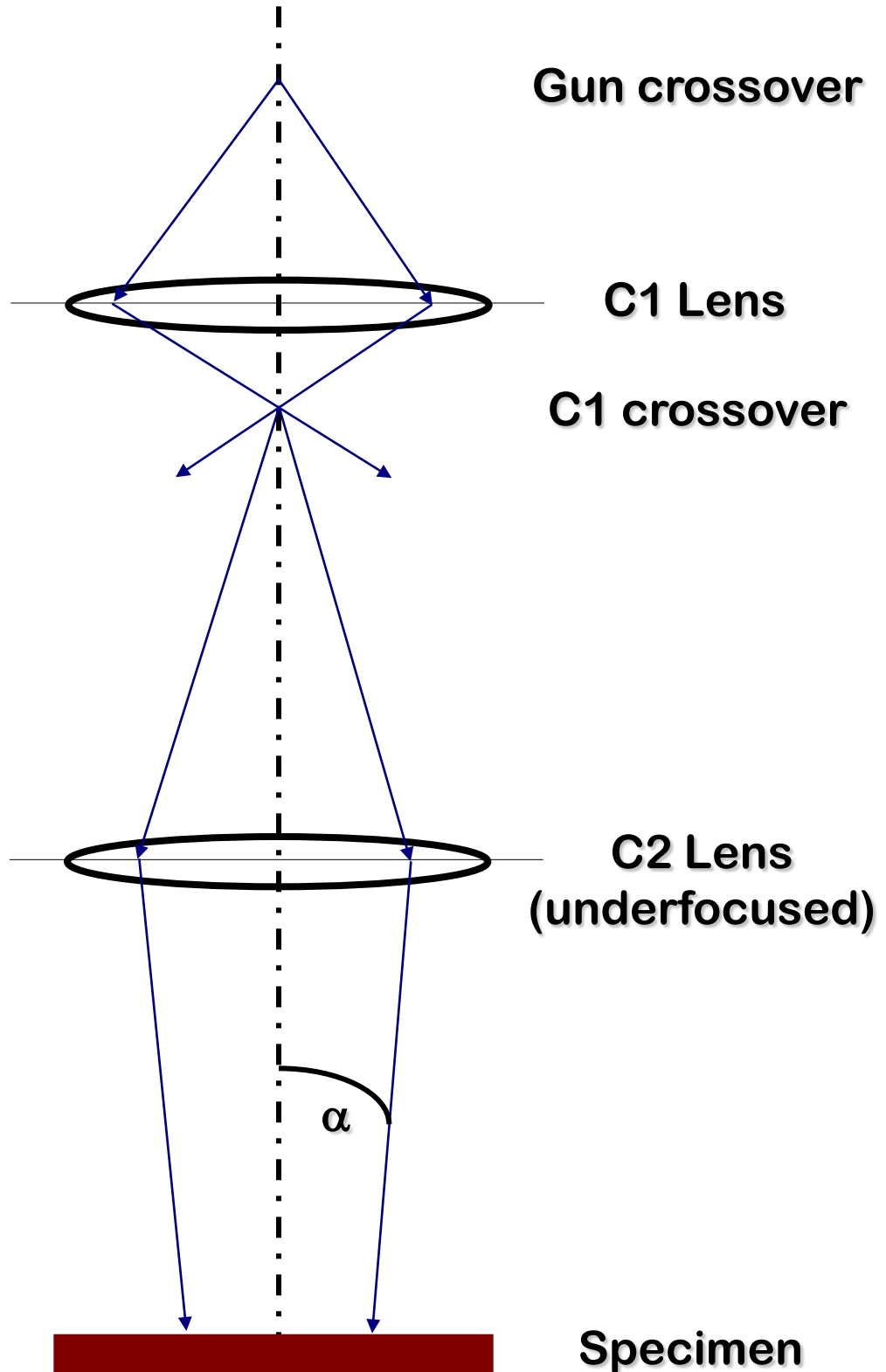
- **Probe size**
- **Convergence angle**
- **Intensity (brightness)**

Imaging modes & uses:

- **Parallel illumination**
 - **Approximately - routine**
 - **Perfectly (Köhler)**
- **Focused illumination**
 - **Microdiffraction / EDS / EELS**
 - **Convergent beam diffraction**
- **Translating / tilting the beam**
 - **Bright field / dark field**
 - **Scanning TEM imaging**

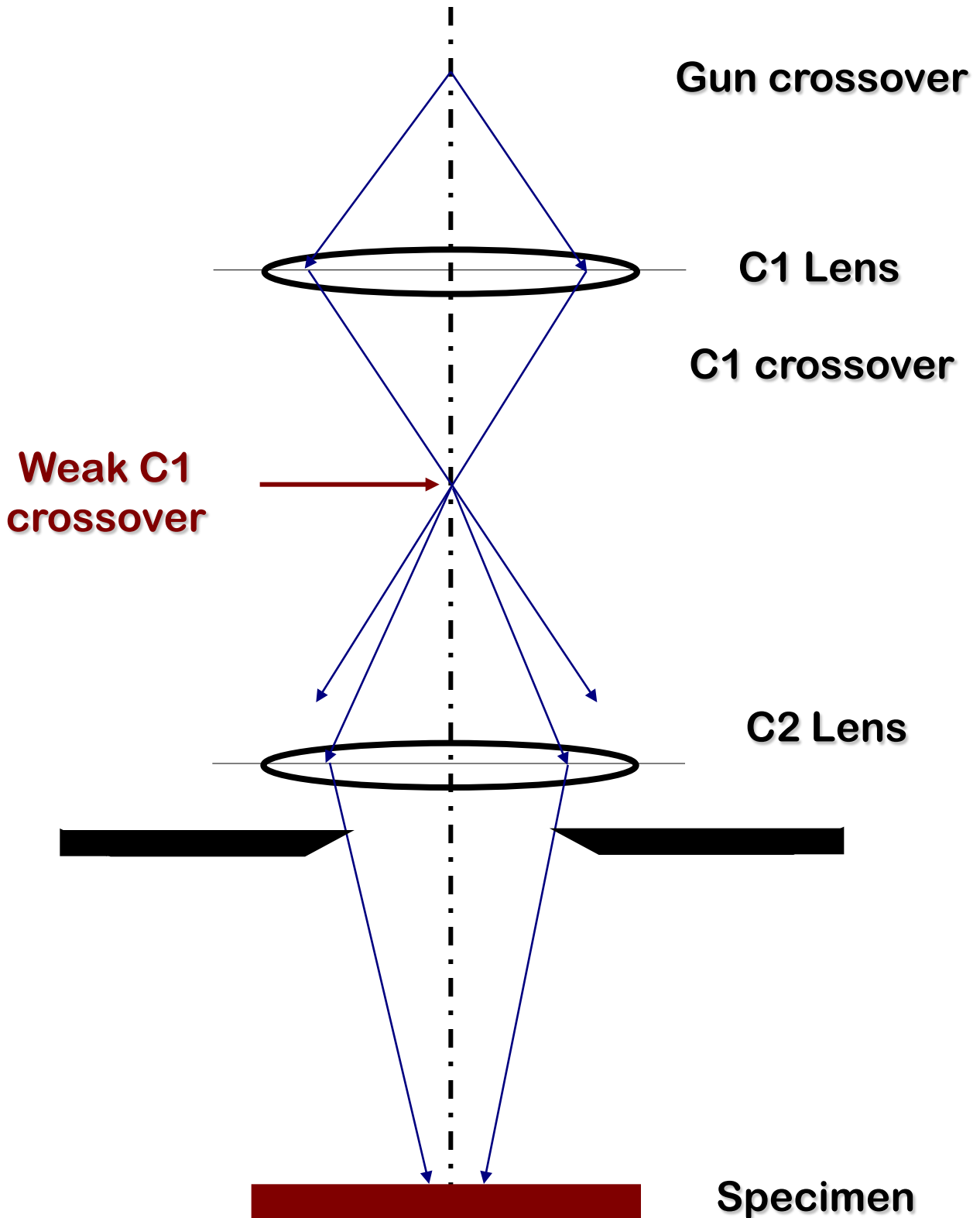
Condenser system

“parallel beam”



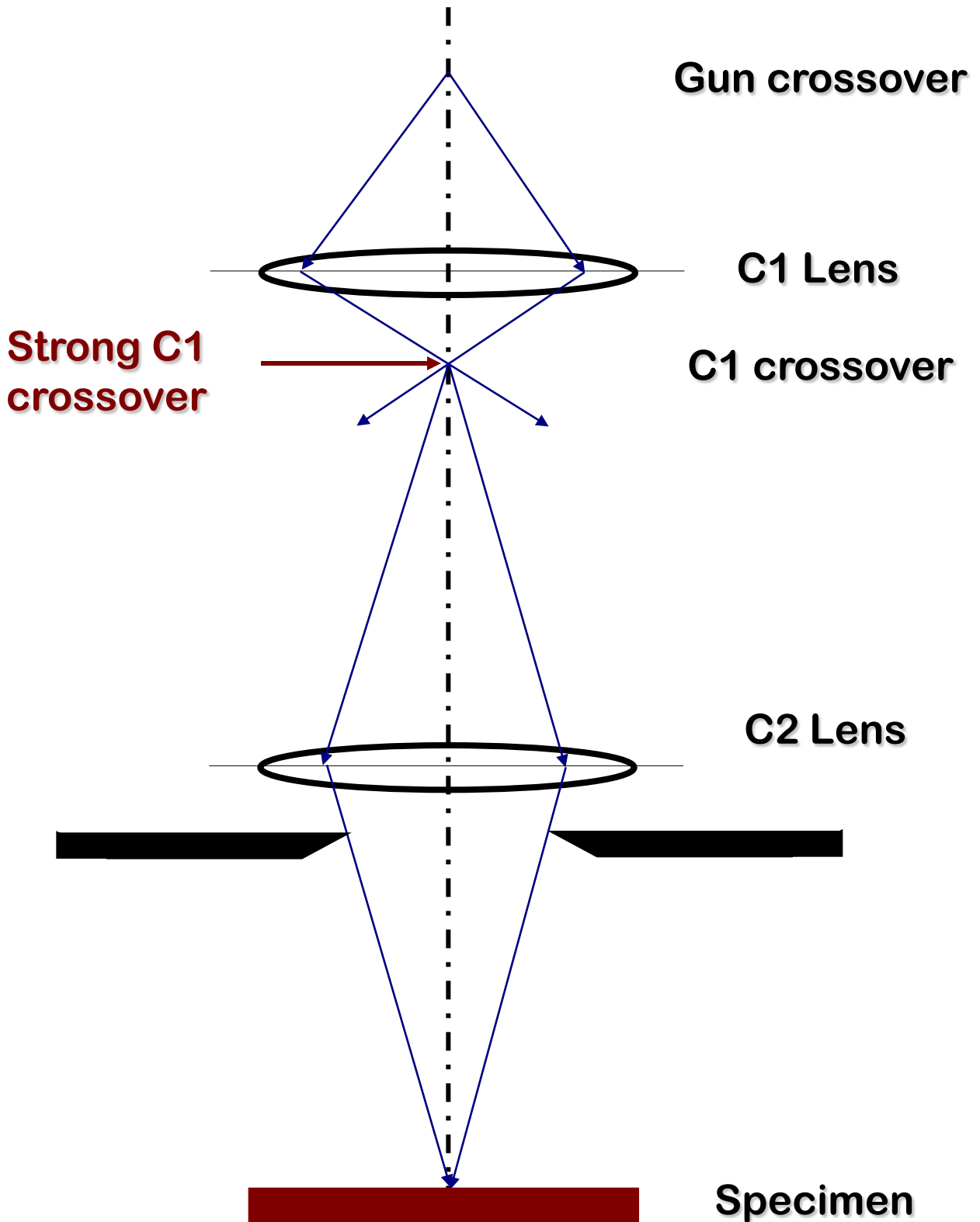
Condenser system

effect of C1 strength - "spot size"



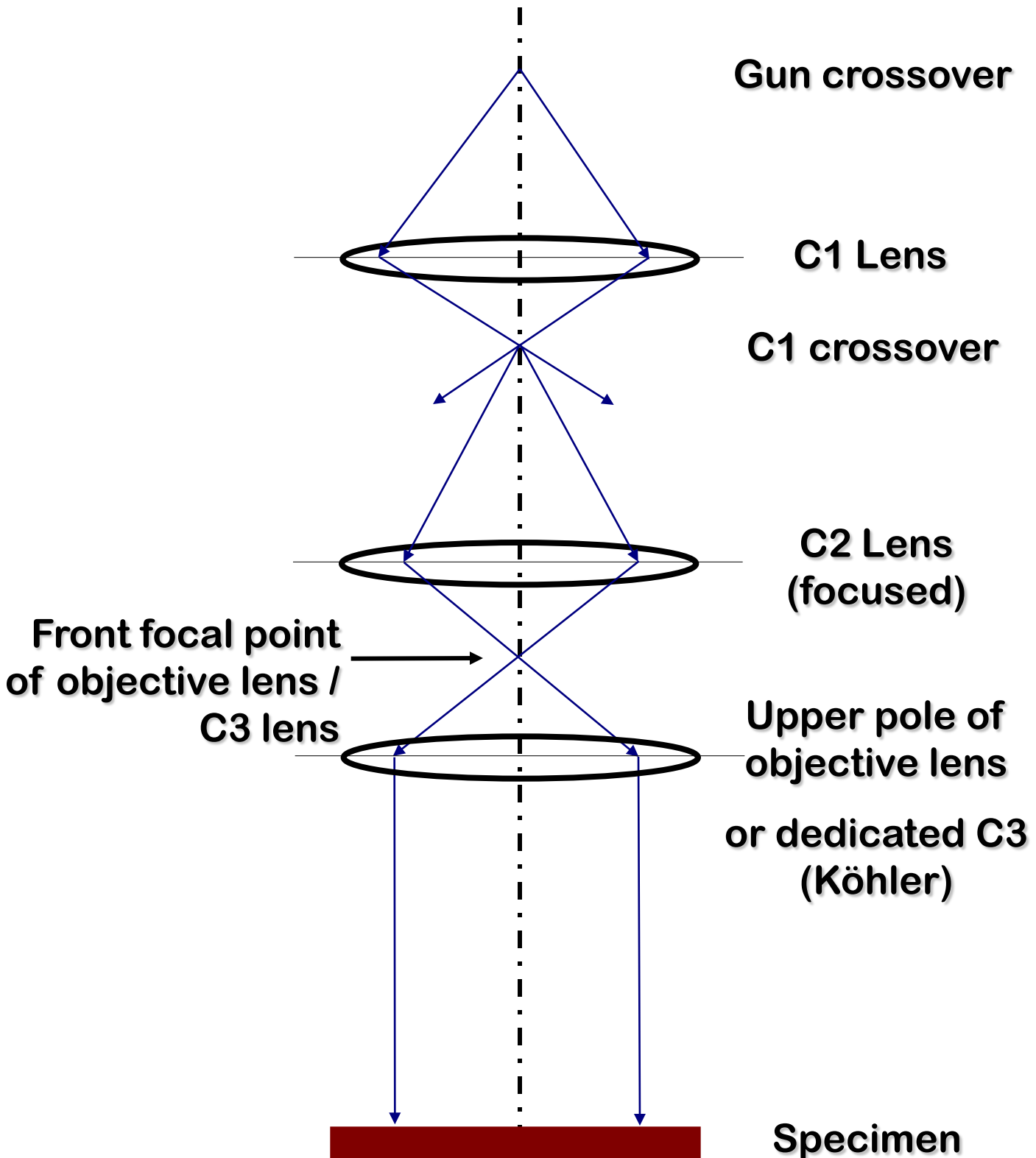
Condenser system

effect of C1 strength - "spot size"



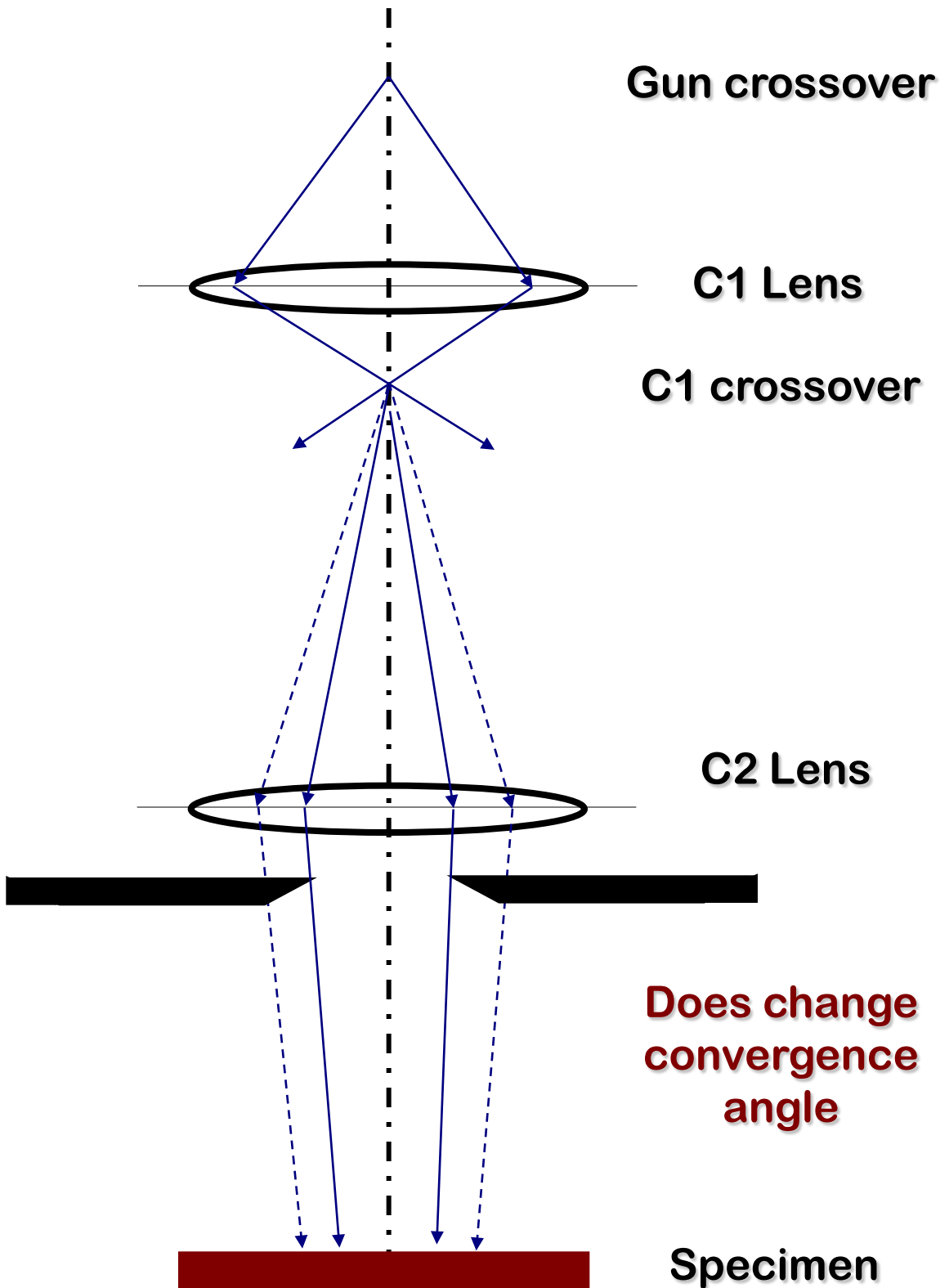
Condenser system

parallel illumination (Köhler)



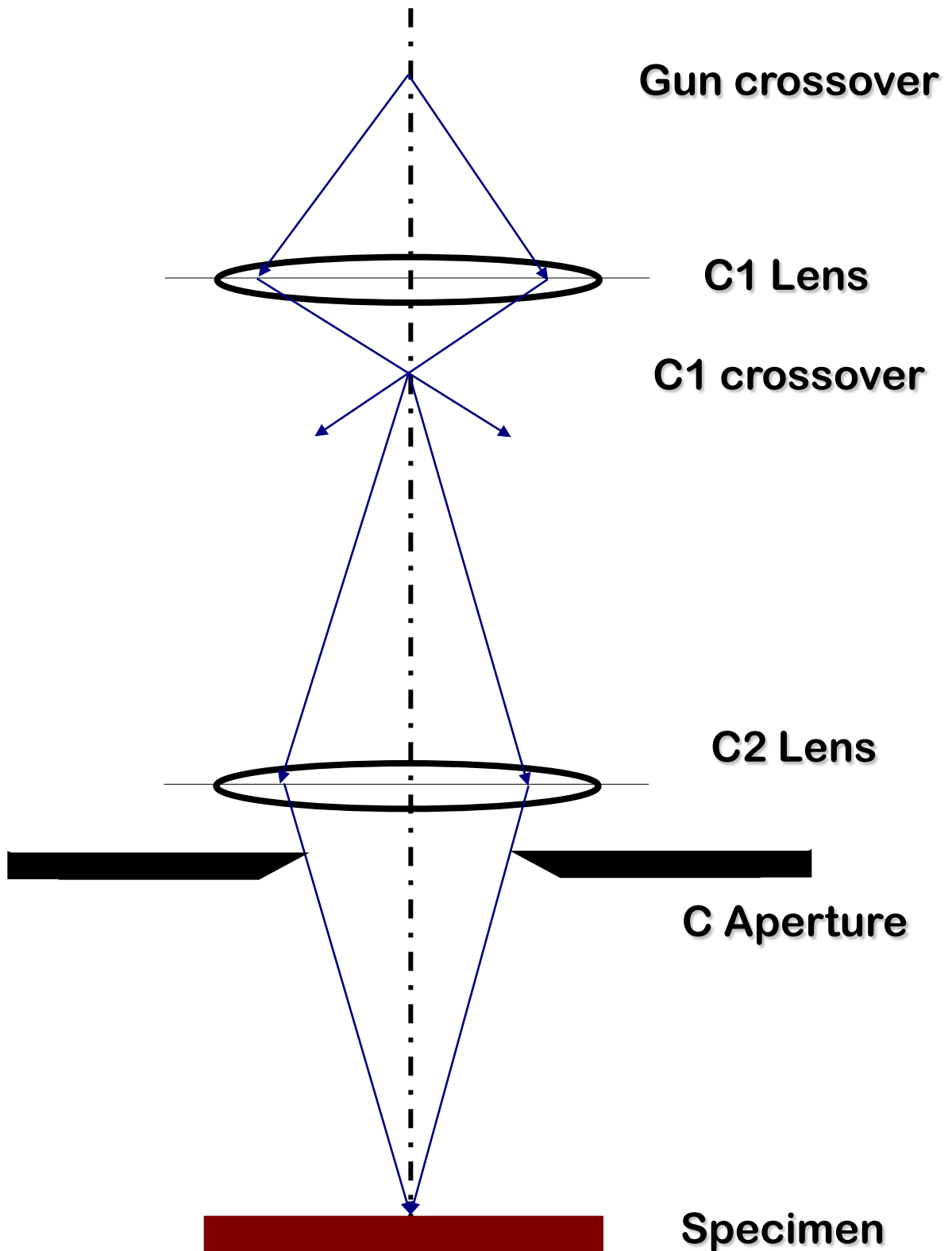
Condenser system

aperture effect



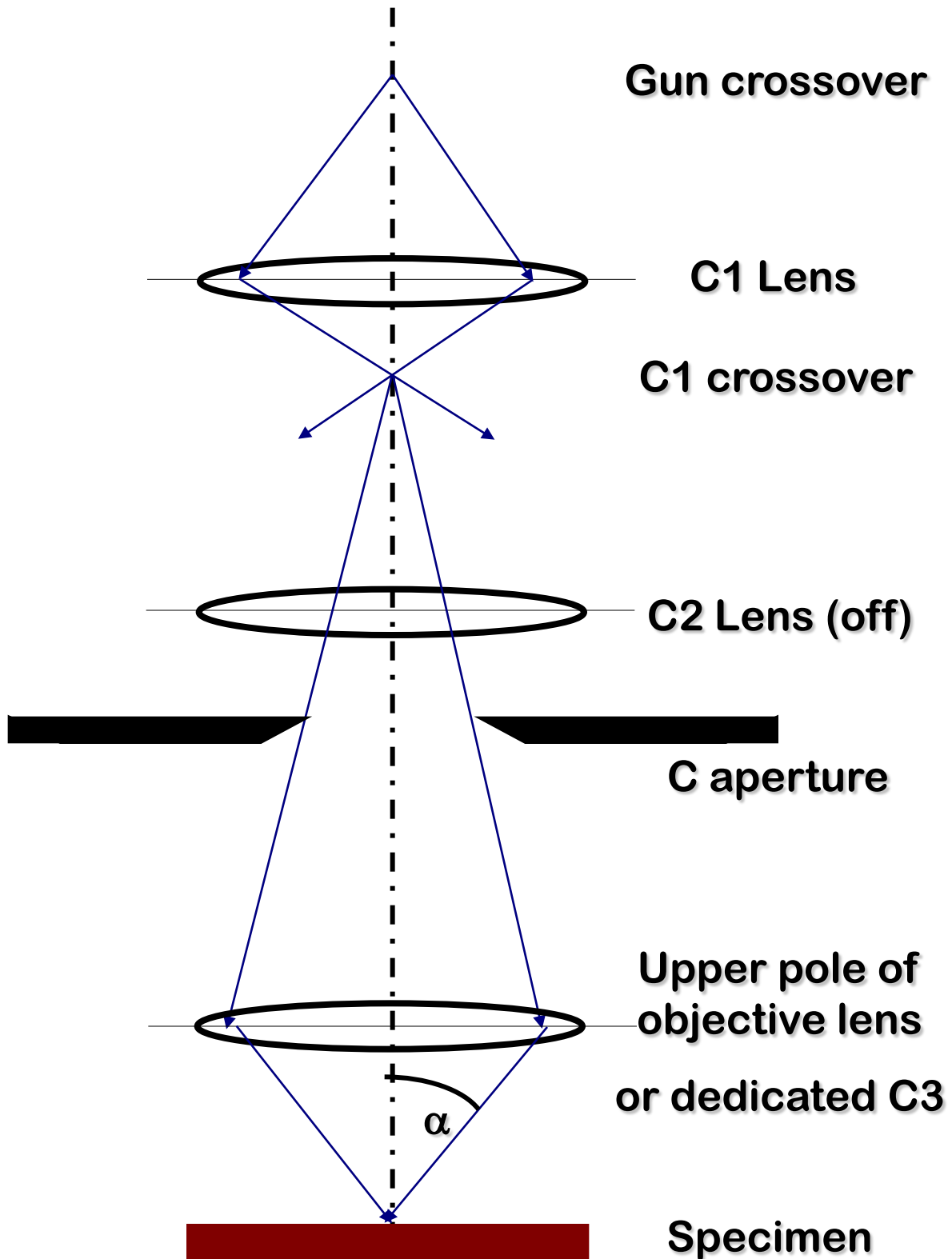
Condenser system

focused probe



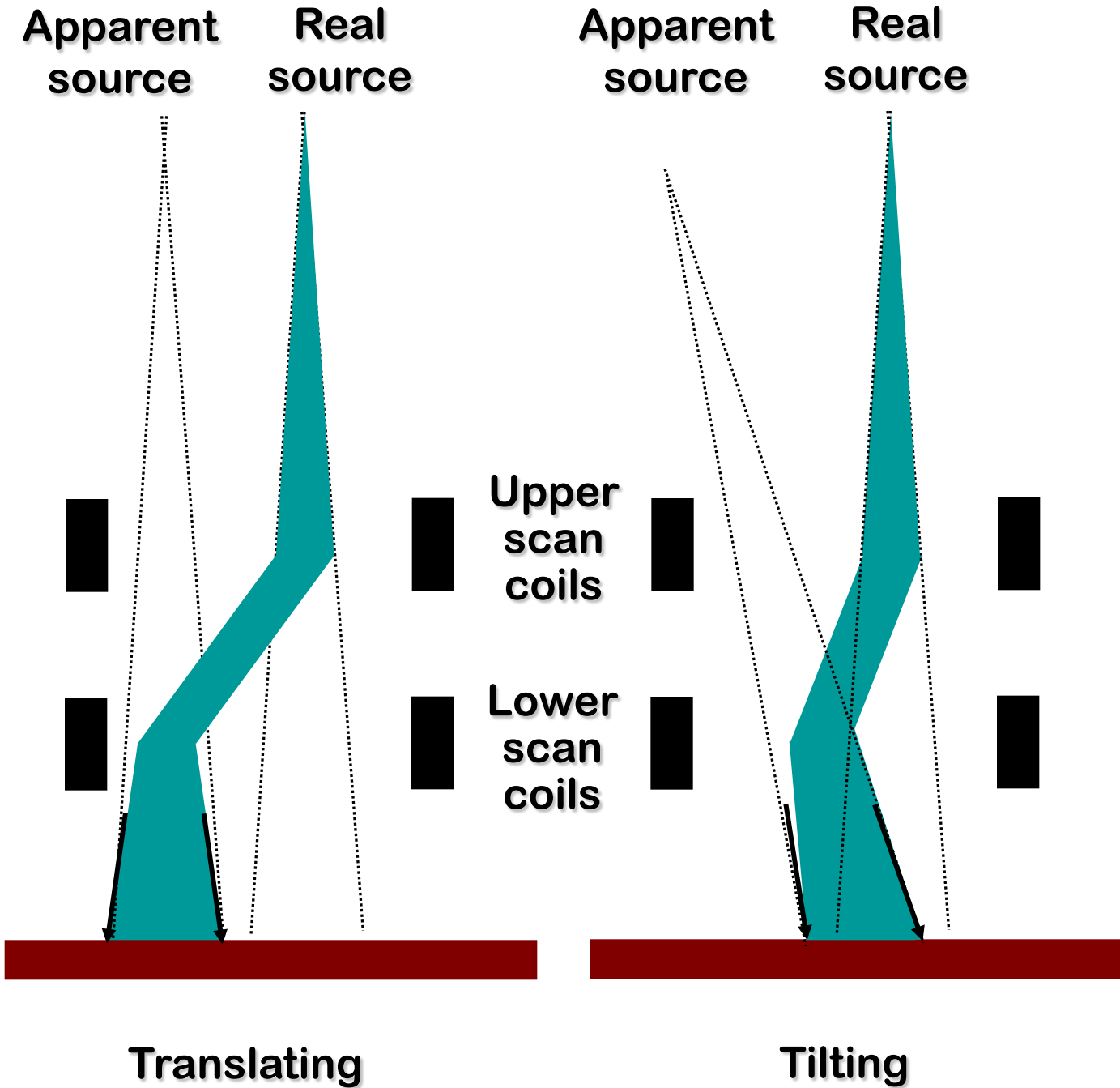
Condenser system

'convergent beam' focused probe



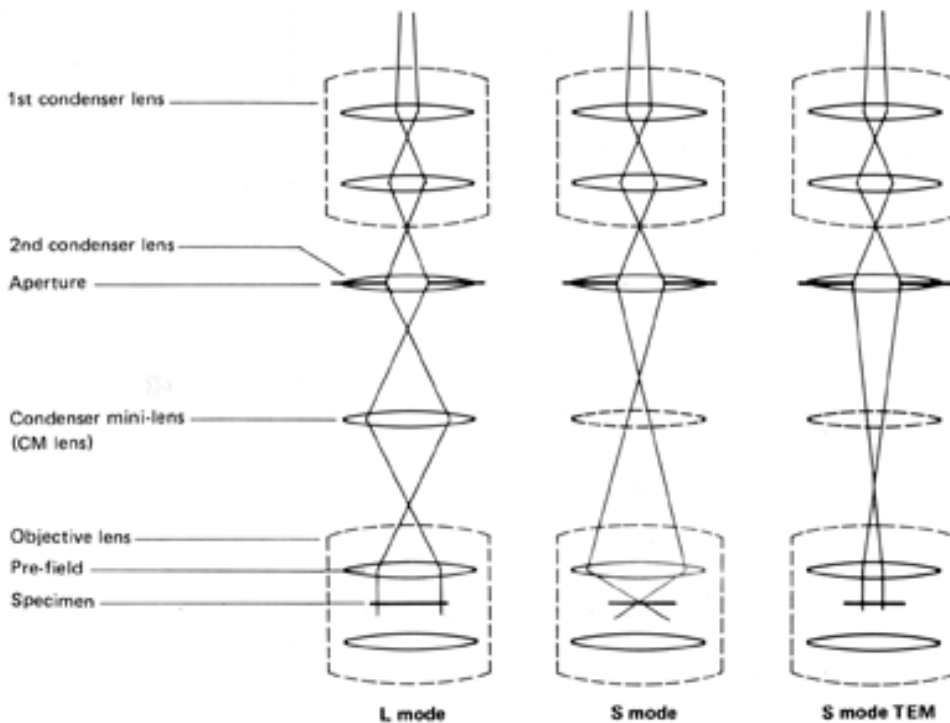
Condenser system

scanning / tilting & translating



Condenser system

Actual ray diagrams are always available in the operation manual of the microscope



Mode	L	S
Probe dia.	1 μm λ 20 nm	40 nm λ 2 nm
TEM low mags.	○	×
TEM high mags.	○	○
SA diff.	○	×
CBE diff.	×	○
HD diff.	○	○

L mode: Fine Probe mode. For TEM observation.

S mode: Super Focus mode. For analysis and convergent beam electron diffraction.

S mode TEM: For TEM observation in the S mode.

Objective & Imaging system

Relationship between sample & object plane

TEM mode

- Forming images
 - Bright field
 - Dark field
 - HREM
- Forming diffraction patterns

STEM mode

- Scanning
- Bright field STEM
- Dark field STEM
- Annular dark field STEM

Eucentric position

Optimum position of sample

- Where it does not translate when you tilt

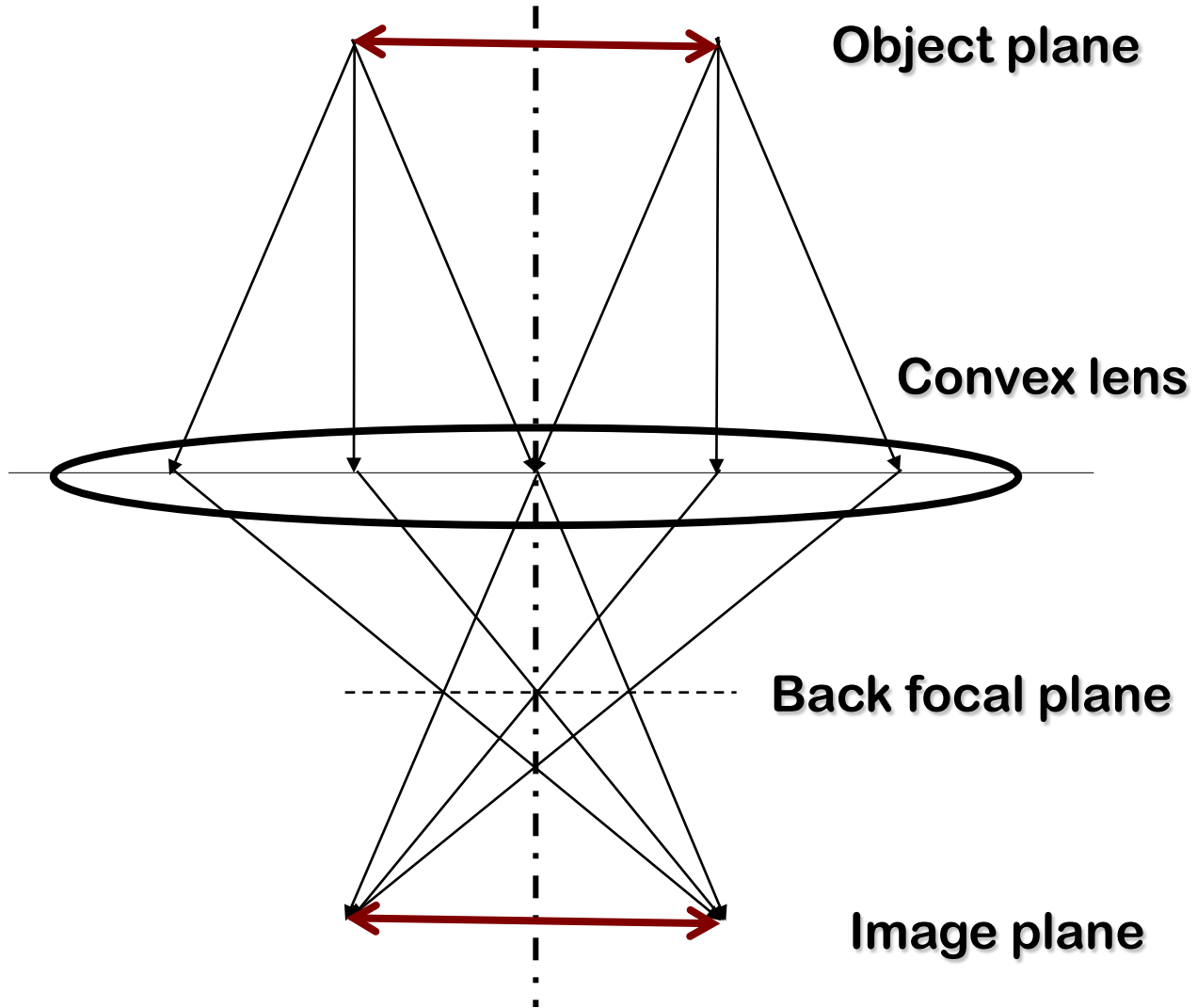
This defines the 'object' plane

In older systems, you then set the microscope's lens strength to make it coincide with the object

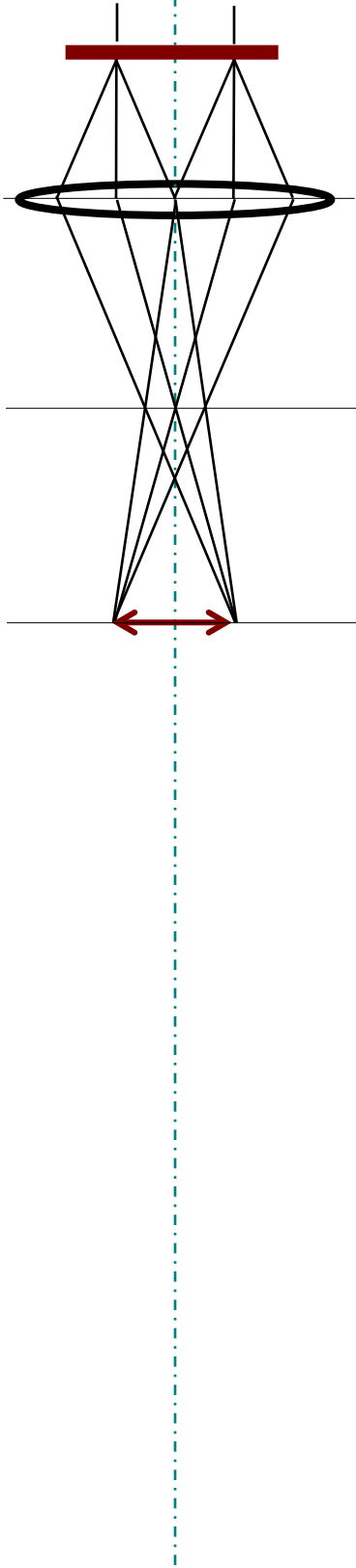
In newer systems, the physical location is known, yielding a fixed objective lens current

- This is better
 - No need to change lens current during imaging
 - Greater stability

Recall ...



TEM imaging



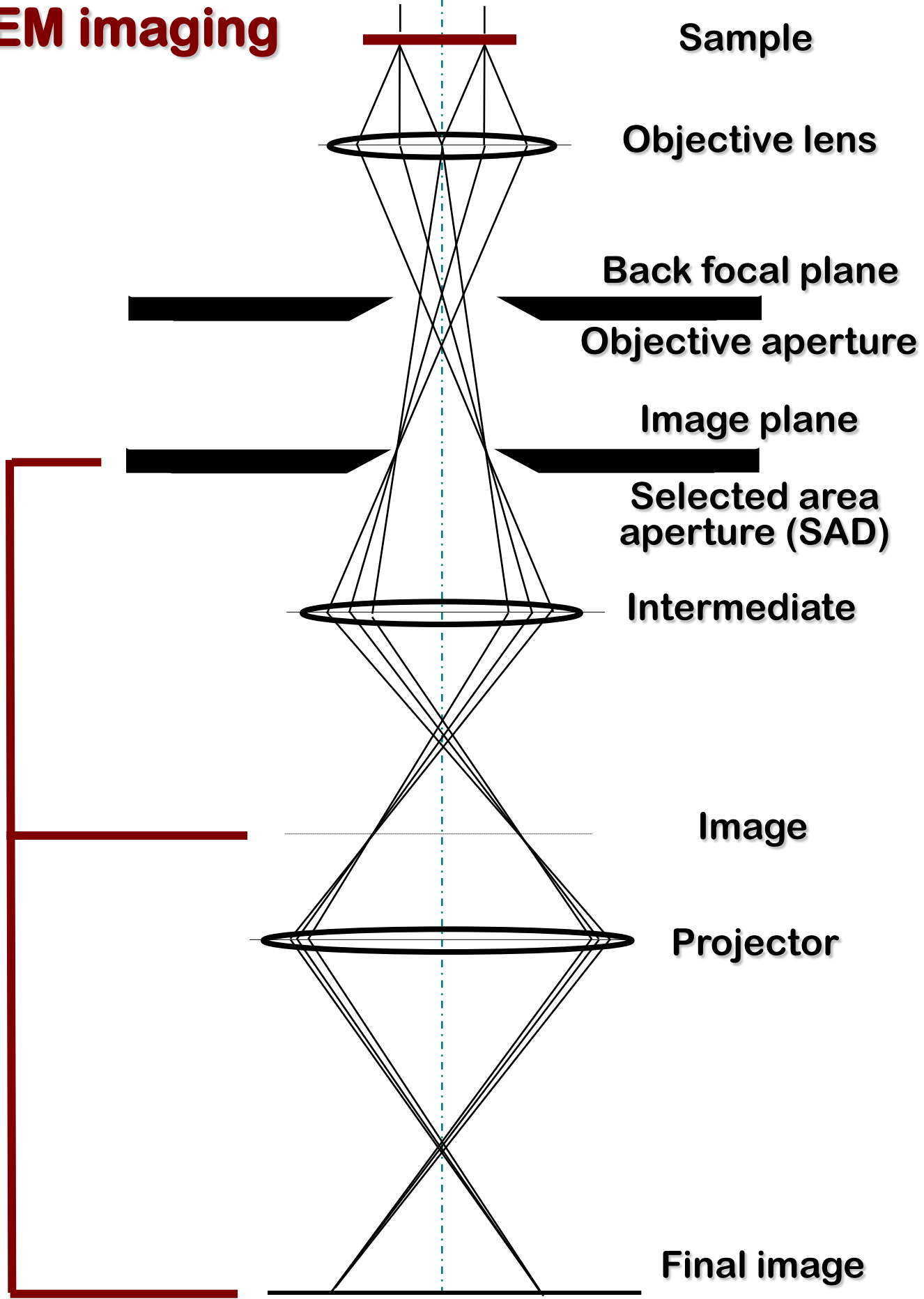
Sample

Objective lens

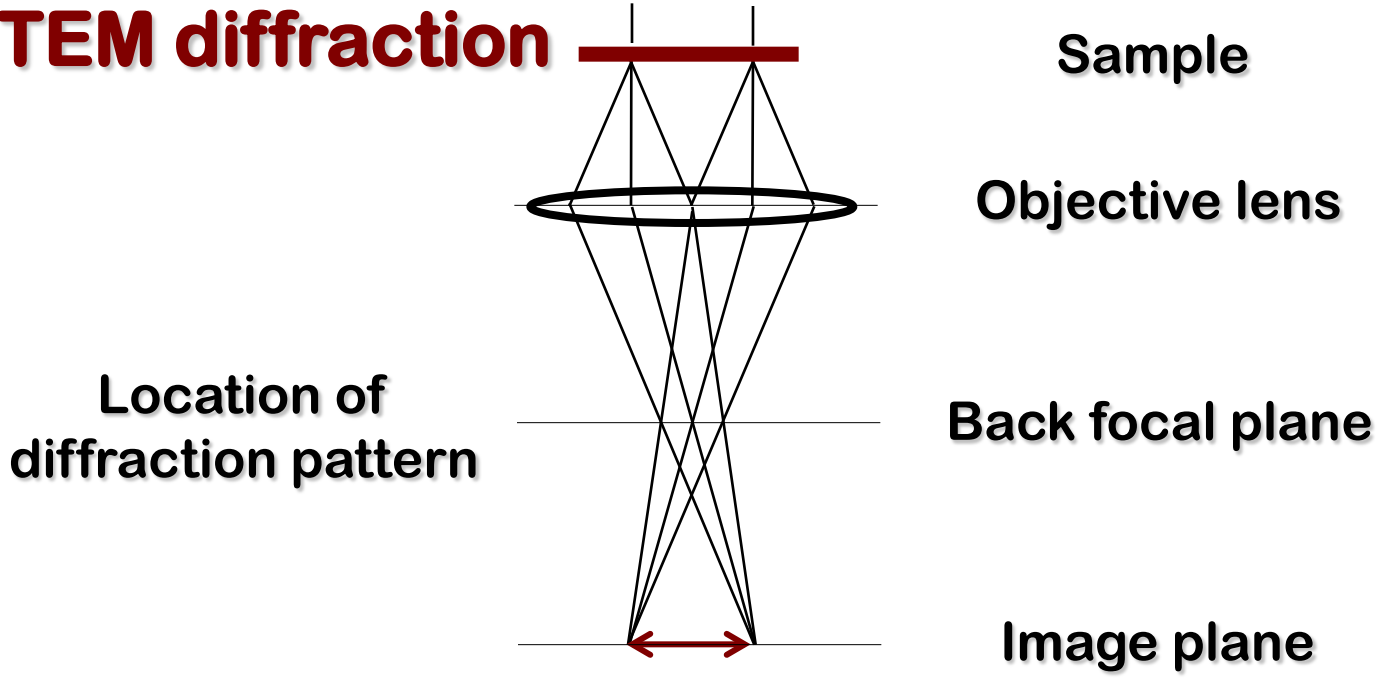
Back focal plane

Image plane

TEM imaging



TEM diffraction



Sample

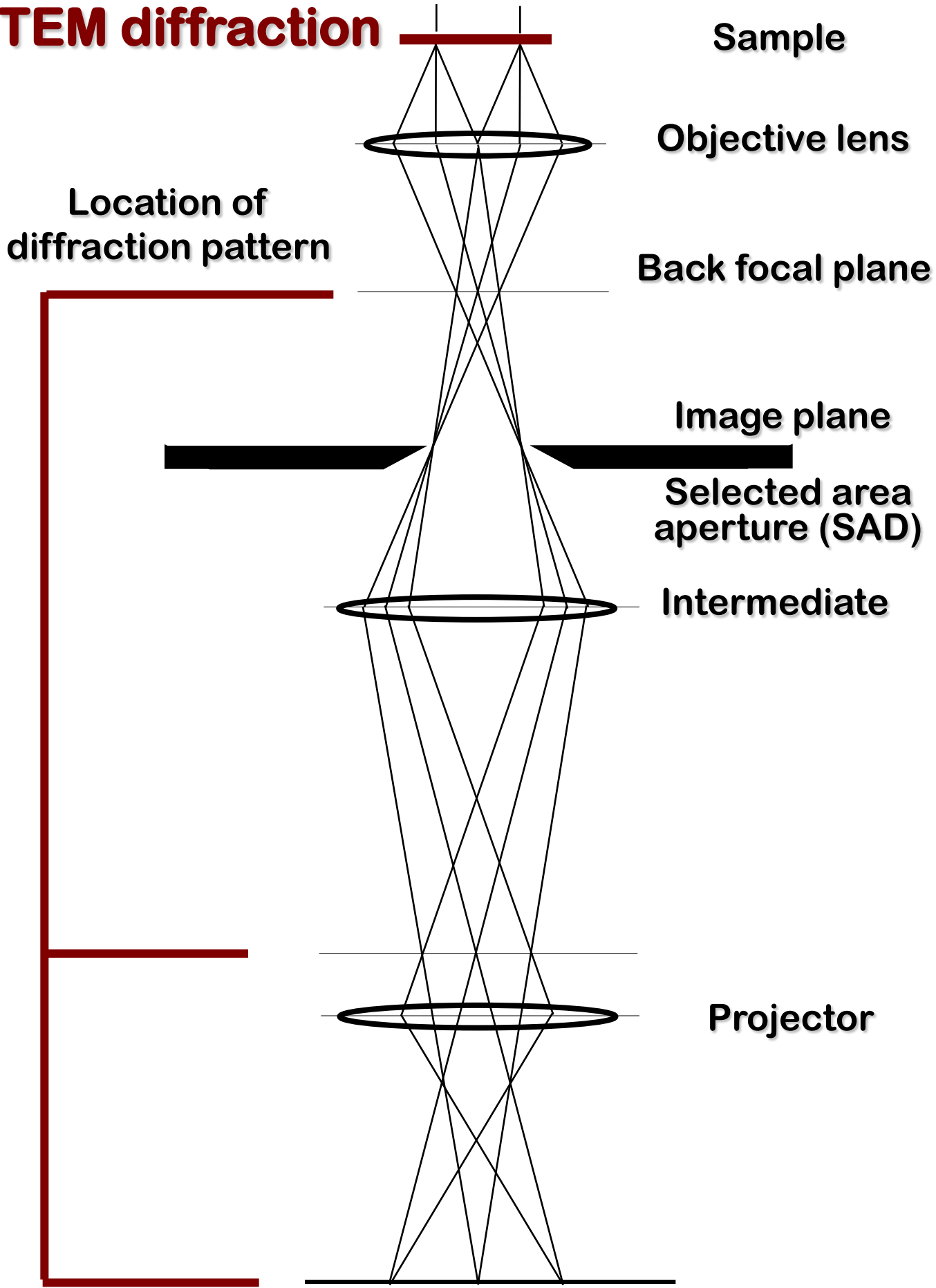
Objective lens

Back focal plane

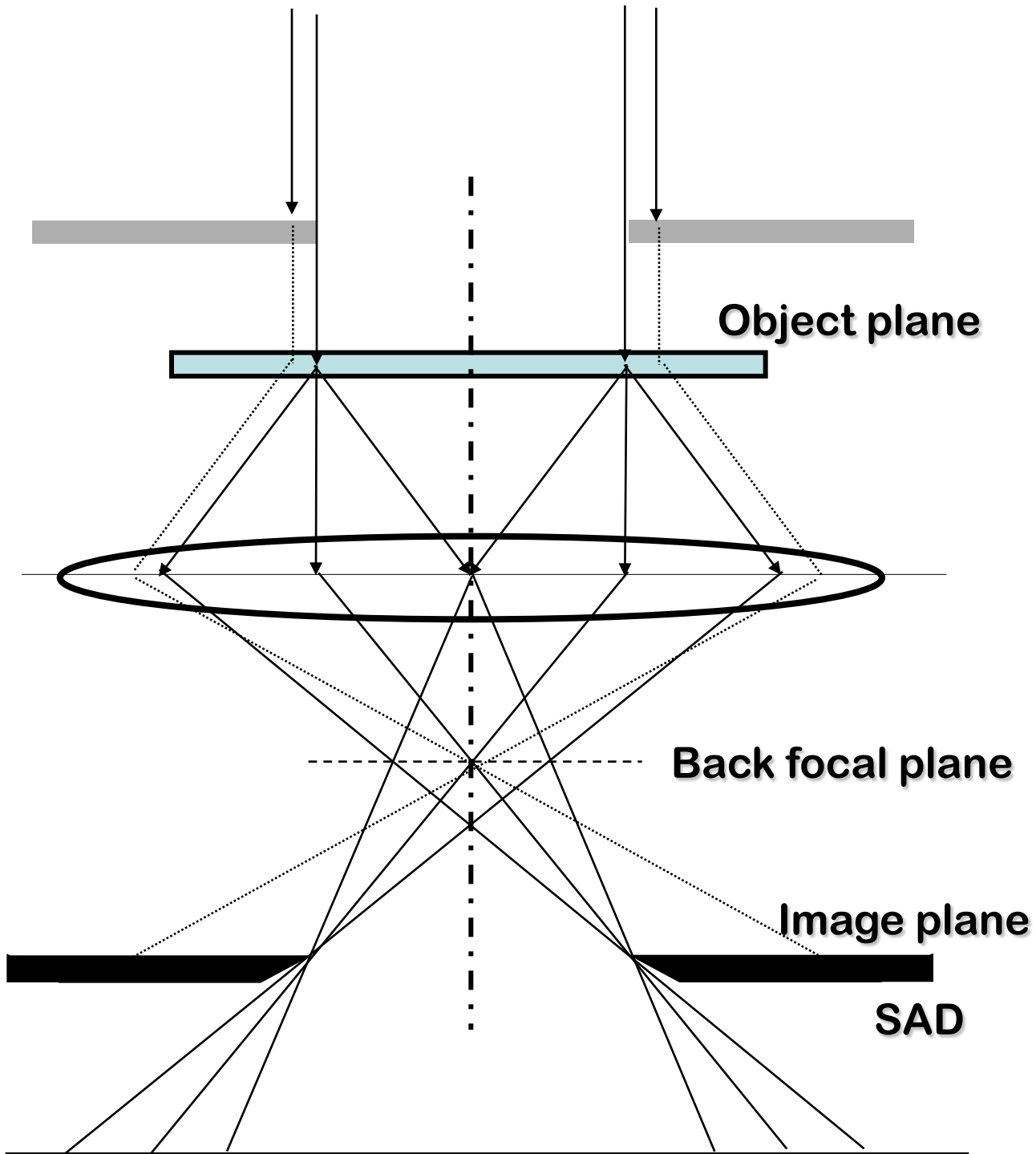
Image plane

**Location of
diffraction pattern**

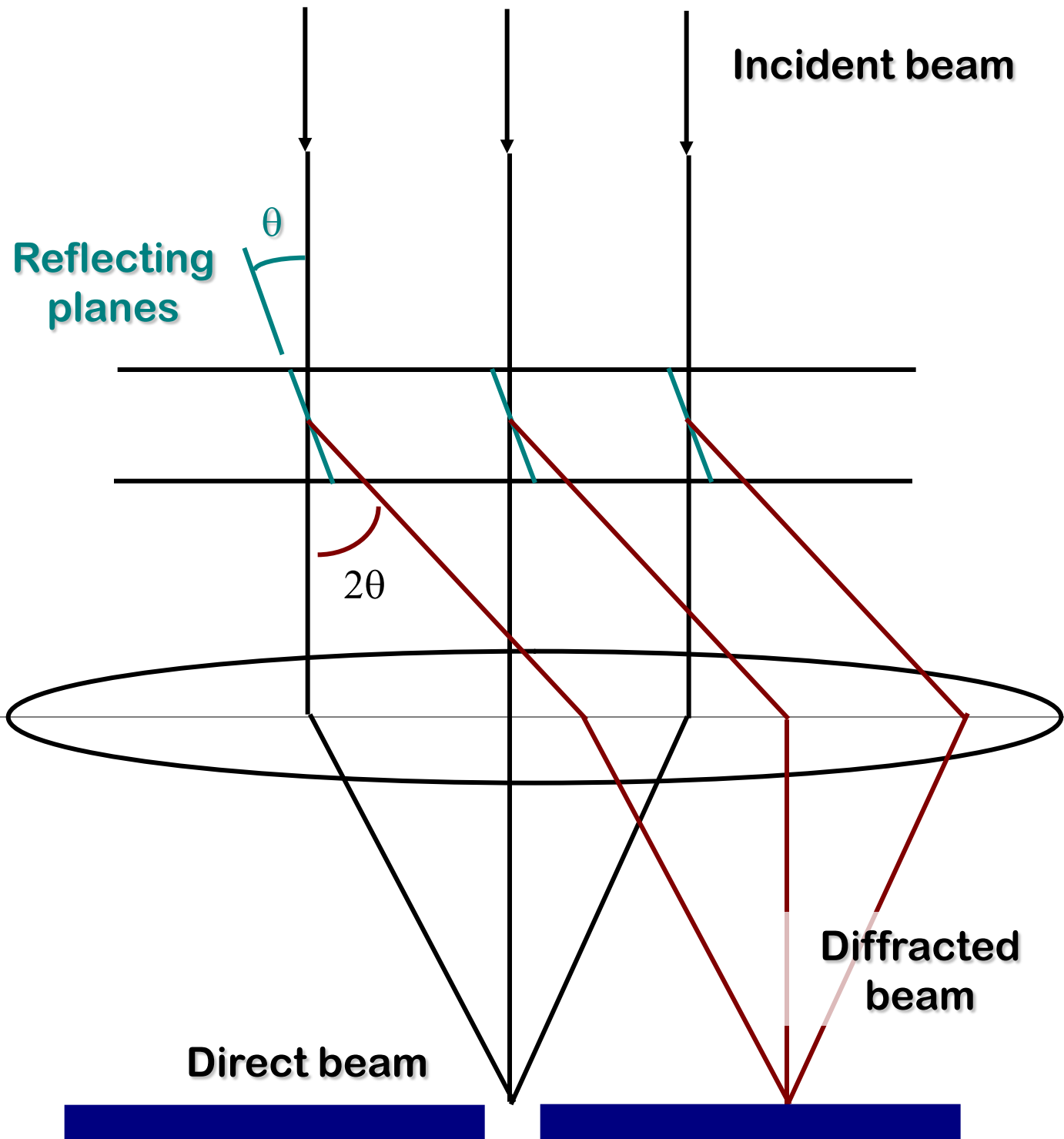
TEM diffraction



Selected area diffraction aperture



Bright field image



“Dirty” dark field

